OLIFF & BERRIDGE, PLC

ATTORNEYS AT LAW

Application Data Sheet

Application Information

Application Type::

Regular

Subject Matter::

Utility

CD-ROM or CD-R:

None

Title::

AN ANTI-REFLECTION FILM MATERIAL AND A SUBSTRATE HAVING AN ANTI-REFLECTION

FILM AND A METHOD FOR FORMING A

PATTERN

Attorney Docket Number::

118988

Suggested Drawing Figure::

Total Drawing Sheets:

3

Small Entity::

No

Applicant Information

Applicant Authority type::

Inventor

Primary Citizenship Country::

Japan

Status::

Full Capacity

Given Name::

Jun

Family Name::

HATAKEYAMA

City of Residence::

Niigata

Country of Residence::

JAPAN

Applicant Authority type::

Inventor

Primary Citizenship Country::

Japan

Status::

Full Capacity

Given Name::

Takafumi

Family Name::

UEDA

City of Residence::

Niigata

Country of Residence::

JAPAN

Applicant Authority type::

Inventor

Primary Citizenship Country::

Japan

Status::

Full Capacity

Given Name::

Tsutomu

Family Name::

OGIHARA

City of Residence::

Niigata

Country of Residence::

JAPAN

Applicant Authority type::

Inventor

Primary Citizenship Country::

Japan

Status::

Full Capacity

Given Name::

Motoaki

Family Name::

IWABUCHI

City of Residence::

Niigata

Country of Residence::

JAPAN

Correspondence Information

Correspondence Customer Number::

25944

Foreign Priority Information			
Country::	Application Number::	Filing Date::	Priority Claimed::
JAPAN	2003-81205	3/24/2003	Yes
Country::	Application Number::	Filing Date::	Priority Claimed::
JAPAN	2003-369596	10/29/2003	Yes
Assignee Information	on		
Assignee Name:: Street of mailing address:: City of mailing address:: State or Province of mailing address:: Country of mailing address:: Postal or Zip Code of mailing address::		SHIN-ETSU CHEMICAL CO., LTD. 6-1, Ohtemachi 2-chome, Chiyoda-ku, Tokyo JAPAN 100-0004	